

Title (en)
Gas exhausting device

Title (de)
Gasableitungsanordnung

Title (fr)
Dispositif d'évacuation de gaz

Publication
EP 2072896 A3 20150527 (DE)

Application
EP 08021828 A 20081216

Priority
DE 202007017770 U 20071220

Abstract (en)
[origin: EP2072896A2] The arrangement (10) has a gas conveying device (12) coupled at a gas discharge system (26). A flow of gases is caused along a gas flow characteristics (V) by using the gas conveying device. The gases are discharged by the gas discharge system and the gas conveying device. An exhaust muffler (14) e.g. passive muffler, stands in a flow connection with the gas conveying device. The muffler is provided with muffler elements (16, 18) assigned to different sound ranges, and is arranged opposite to the gas conveying device relative to the gas flow characteristics.

IPC 8 full level
F23J 13/00 (2006.01)

CPC (source: EP)
F23J 13/00 (2013.01); **F23J 2900/13003** (2013.01)

Citation (search report)

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Designated contracting state (EPC)
AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MT NL NO PL PT RO SE SI SK TR

Designated extension state (EPC)
AL BA MK RS

DOCDB simple family (publication)
DE 202007017770 U1 20090423; EP 2072896 A2 20090624; EP 2072896 A3 20150527

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DE 202007017770 U 20071220; EP 08021828 A 20081216